IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

T. KAJI, et al

Serial No.:

10/090,759

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For:

EMISSION SPECTROSCOPIC PROCESSING APPARATUS

AND PLASMA PROCESSING METHOD USING IT

REAFFIRMATION OF CLAIM FOR PRIORITY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 11, 2003

Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 2001-364626, filed in Japan on November 29, 2001.

The certified copy of the above-referred to Japanese Patent Application was filed on April 29, 2002 in prior application Serial No. 10/090,759, filed March 6, 2002.

Respectfully submitted,

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